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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: John C. Bruce et al.

Examiner: Unassigned

Serial No.: 10/778,006

Group Art Unit: Unassigned

Filed: February 12, 2004

Docket No.: PD-242.00 / M190.150.101

Title: **CONTACT TONOMETER USING MEMS TECHNOLOGY**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir/Madam:

We are transmitting herewith the attached:

- ☒ Transmittal Sheet containing Certificate of Mailing (1 pg.).
- ☒ Information Disclosure Statement (2 pgs.).
- ☒ Form PTO-1449 (2 pgs.) citing:
 - eighteen (18) U.S. art references;
 - zero (0) foreign art references; and
 - four (4) other art documents.
- ☒ A copy of four (4) Other Art Document(s).
- ☒ Return Postcard.

Please consider this a PETITION FOR EXTENSION OF TIME for a sufficient number of months to enter these papers, if appropriate. At any time during the pendency of this application, please charge any additional fees or credit overpayment to Deposit Account No. 50-0471.

Please send all correspondence to:

MEDTRONIC, INC.
Attn: Patent Department
710 Medtronic Parkway
Minneapolis, MN 55432

By: 

Name: Timothy A. Czaja

Reg. No.: 39,649

CERTIFICATE UNDER 37 C.F.R. 1.8:

The undersigned hereby certifies that this paper or papers, as described herein, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 23rd day of July, 2004.

By: 

Name: Timothy A. Czaja



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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement be entered and the documents listed on attached form 1449 be considered by the Examiner and made of record. Any required copies of patents, publications or other documents are enclosed for the Examiner's review. Pursuant to the provisions of M.P.E.P. 609, Applicant further requests a copy of the 1449 form, marked as being considered and initialled by the Examiner, be returned with the next Official Communication.

Since this Information Disclosure Statement is being submitted within three months of filing national application; or date of entry of national application; or before the mailing date of the first Office Action on the merits, a fee has not been enclosed. However, if such fee is required, the Patent Office is hereby authorized to charge Deposit Account No. 500471 for fees as set forth under 37 C.F.R. 1.17(p).

Applicant respectfully requests consideration of these references during prosecution of the above-identified matter. The Examiner is invited to contact the Applicant's representative at the below-listed telephone number if there are any questions regarding this Communication or the tendered references.

Information Disclosure Statement

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In addition, all correspondence should continue to be directed to the following address:

MEDTRONIC, INC.

Attn: Patent Department

710 Medtronic Parkway

Minneapolis, MN 55432

Respectfully submitted,

John C. Bruce et al.,

By their attorneys,

DICKE, BILLIG & CZAJA, PLLC

Fifth Street Towers, Suite 2250

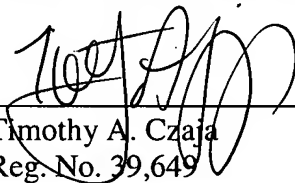
100 South Fifth Street

Minneapolis, MN 55402

Telephone: (612) 573-2004

Facsimile: (612) 573-2005

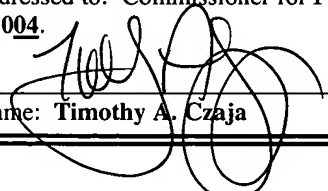
Dated: July 23rd, 2004
TAC:jmc



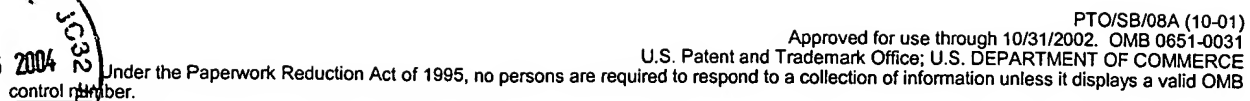
Timothy A. Czaja
Reg. No. 39,649

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By 

Name: Timothy A. Czaja



**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(use as many sheets as necessary)

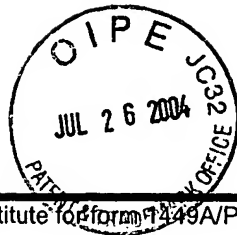
Application Number	10/778,006
Filing Date	02/12/2004
First Named Inventor	Bruce, John C.
Art Unit	3736
Examiner Name	
Attorney Docket Number	PD-242.00/M190.150.101

Sheet	1	of	2
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Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
		US-6,746,400	06-08-2004	Rathjen	
		US-4,747,296	05/31/1988	Feldon, et al.	
		US-6,408,878	06/25/2002	Unger, et al.	
		US-6,367,333	04/09/2002	Bullister, et al.	
		US-6,341,528	01/29/2002	Hoffman, et al.	
		US-6,183,097	02/06/2001	Screef, et al.	
		US-6,460,234	10/08/2002	Gianchandani	
		US-6,188,477	02/13/2001	Pu, et al.	
		2002/0121135	09/05/2002	Rediniotis, et al.	
		2002/0115920	08/22/2002	Rish, et al.	
		2002/0073783	06/20/2002	Wilner, et al.	
		2002/0049394	04/25/2002	Roy, et al.	
		2002/0045921	04/18/2002	Wolinsky, et al.	
		2002/0029814	03/14/2002	Unger, et al.	
		2002/0029639	03/14/2002	Wagner, et al.	
		6,447,449	09/10/2002	Fleischman, et al.	
		2002/0177768	10/28/2002	Fleischman, et al.	
		2002/0193674	12/19/2002	Fleischman, et al.	

[illegible]

Examiner Initials*	Cite No. ¹		Publication Date MM-DD-YYYY	Name of Author	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Title			
		Force-Sensing Microprobe for Precise Stimulation of Mechanosensitive Tissues	08/08/1995	Kane, B.J., et al.	pp745-750
		Wireless Micromachined Ceramic Pressure Sensors	1999	English, J.M., et al.	pp. 511-516
		Micro-Diaphragm Pressure Sensor	1986	S. Sugiyama, et al.	pp. 184-7
		MOS Integrated Silicon Pressure Sensor	07/15/1985	H. Tanigawa, et al.	pp. 1191



Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	10/778,006
				Filing Date	02/12/2004
				First Named Inventor	Bruce, John C.
				Art Unit	3736
				Examiner Name	
Sheet	2	of	2	Attorney Docket Number	PD-242.00/M190.150.101

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04.

³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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